



PATENT  
Attorney Docket No. 03180.0350

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Hiroko NAKAMURA et al. )  
Application No.: 10/760,522 )  
Filed: January 21, 2004 ) Group Art Unit: 2123  
For: A METHOD FOR A PREDICTING A )  
PATTERN SHAPE BY USING AN )  
ACTUAL MEASURED ) Examiner: Dwin M. Craig  
DISSOLUTION RATE OF A ) Confirmation No.: 1093  
PHOTOSENSITIVE RESIST (As )  
amended) )

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT**

In reply to the Office Action mailed December 20, 2006, the period for response having been extended to May 21, 2007 (May 20, 2007, being a Sunday) by a Petition for Extension of Time of two months and fee payment to be drawn from Deposit Account 06-0916, please amend the above-identified application as follows:

**Amendments to the Specification** are included in this paper.

**Amendments to the Claims** are reflected in the listing of claims in this paper. 05/22/2007 1001150 060916 10760522

**Remarks** follow the amendment sections of this paper. 01 FC:1252 450.00 DA  
02 FC:1201 200.00 DA

Attachments to this paper include a copy of a PTO Form 1449 included with an Information Disclosure Statement (IDS) submitted August 12, 2004.